

FORM PTO-1449 (Modified)	U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY.DOCKET NO. 05714 USA	SERIAL NO.
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		APPLICANT Cutler, et al.	
		FILING DATE 27 April 2001	GROUP 1745

J1016 U. S. PTO
09/843519
04/27/01

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER							DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
		YES	NO											
13	H	8	1	6	9	7	1	3	07/02/96	Japan	C01F	17/00	X	
13		5	0	1	2	5	6	6	05/13/75	Japan	H01M	8/12	X	
13		9	1	0	9	4	3	0	06/27/91	World	H01M	8/12	X	
13		1	3	2	2	9	5	9	07/11/73	Great Britain	H01M	27/16	X	
		6	2	2	8	3	1	6	1994	Japan	C08Q	77/38		X

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

11		<p>Chen & Chen, "Grain Growth in CeO_2: Dopant Effects, Defect Mechanism, and Solute Drag," (J. Am. Ceram. Soc. No. 79 (1996) p. 1793) <u>no month available</u></p> <p>Baumard and coworkers, "Sintered Ceria: A New Dense and Fine Grained Ceramic Material," (J. Less Com. Metals, 127, 125-130 (1987)) <u>no month available</u></p>
12		

EXAMINER Amy Tsang-Foster DATE CONSIDERED 3/15/03

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.